

In re: Koh et al.
Serial No.: 09/891,905
Filed: June 26, 2001
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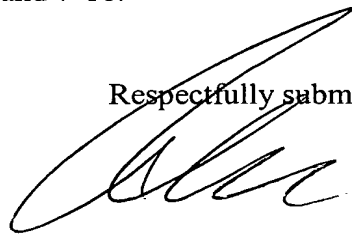
REMARKS

In response to the Restriction Requirement of January 29, 2002, Applicants hereby elect Invention II, corresponding to Claims 1-4 and 7-16, drawn to methods. Applicants have canceled Claims 5-6 corresponding to Invention I which are drawn to integrated circuits. This cancellation is being done without prejudice to the filing of a divisional application for these and/or other claims.

Applicants are not traversing the Restriction Requirement, because Applicants agree that, a determination of the unpatentability of Invention II would not necessarily imply the unpatentability of Invention I.

In view of the above, Applicants respectfully request favorable examination and allowance of Claims 1-4 and 7-16.

Respectfully submitted,



Robert N. Crouse
Registration No. 44,635
Attorney for Applicants



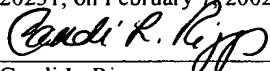
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: BOX NON-FEE AMENDMENT, Commissioner for Patents, Washington, DC 20231, on February 7, 2002.



Candi L. Riggs
Date of Signature: February 7, 2002

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VERSION WITH MARKINGS TO SHOW CHANGES MADE

Sir:

The following is an addendum to the concurrently filed response to a Restriction Requirement dated January 29, 2002 in the above referenced application. This addendum includes a marked-up version of the changes made to the specification by the present amendment.

In the Specification:

The title has been amended as follows:

-- METHODS OF FORMING INTEGRATED CIRCUITS USING MASKS
TO PROVIDE ION IMPLANTATION SHIELDING TO PORTIONS OF A
SUBSTRATE ADJACENT TO AN ISOLATION REGION THEREIN [AND
INTEGRATED CIRCUITS FORMED USING SAME]--.